

**Notice of References Cited**

Application/Control No.

10/814,789

Applicant(s)/Patent Under  
Reexamination  
PARK ET AL.

Examiner

Emmanuel Bayard

Art Unit

2611

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,144,686	09-1992	Yumiba: Takashi; et. al.	382/263
*	B	US-5,517,481	05-1996	Kobayashi, Seiji	369/47.17
*	C	US-6,292,816	09-2001	Kim, Yung-soo	708/323
*	D	US-2004/0165622	08-2004	Lu, Cheng Youn	372/029.021
*	E	US-5,784,304	07-1998	Koike, Shin'ichi	708/322
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
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	X				

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